

ABSTRACT OF THE DISCLOSURE

A projection exposure mask with a small size and low cost for exposing a member to form a continuous pattern and a discontinuous pattern thereon is disclosed. The projection exposure mask has a first mask pattern for exposing the member to form the continuous pattern thereon and a second mask pattern for exposing the member to form the discontinuous pattern thereon. One of the first and second mask patterns is a reflecting type mask pattern, and the other mask pattern is a transmitting mask pattern.